

PATENT
002895 USA PO1/IMPLANT/PARAMETRIC/JB1

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: MITCHELL, Robert et al. Conf.:

Appl. No.: New Group:

Filed: December 11, 2003 Examiner:

For: A METHOD AND APPARATUS FOR PROCESSING
WAFERS

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 11, 2003

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes Amendment to the Specification; and

Remarks.